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PATENT  
Attorney Docket No. 04329.3304-00

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	)	
Ayako NAKANO et al.	)	Group Art Unit: 1756
	)	
Application No.: 10/823,539	)	Examiner: Stephen D. ROSASCO
	)	
Filed: April 14, 2004	)	Confirmation No.: 4440
	)	
For: PATTERN FORMING METHOD AND	)	
SYSTEM, AND METHOD OF	)	
MANUFACTURING A	)	
SEMICONDUCTOR DEVICE	)	

**Mail Stop Amendment**  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed June 1, 2007, the period for response to which extends through September 4, 2007 (September 1 being a Saturday and September 3 being a federal holiday), please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.